# Multi-Technique Scanning Probe Microscope for research in air, controlled gas and liquids



SCANNING PROBE MICROSCOPE

### **ALL IN ONE:**



#### **Model SOLVER P47**

is supplied with universal optical detection measuring head, scanner, and microscope base with powerful HIGH-Q electronics. The ultimate vibration protection design allows obtaining an atomic resolution within proximity of noise levels up to 40 dB without an expensive anti-vibration table. ResonantMode allows easy measurement of biological objects such as cells and DNA; other applications include biological samples, soft polymers, contaminated surfaces and any other pliable surfaces that can be easily damaged during contact AFM.

## The measuring modes available in Solver P47:

#### **Scanning Tunneling Microscopy**

#### **STM Imaging**

STM Topography (I=const)

STM Current Imaging (Z=const)

#### ST Spectroscopy (modulation techniques):

Local Barrier Height Imaging (dl/dZ)

Imaging of Local Spectral Density (dl/dU)

#### **STM Lithography**

#### Scanning Force Microscopy (Atomic Force Microscopy)

#### Contact Mode

Contact AFM (F=const)

Force Imaging (Z=const)

Lateral Force Imaging (LFM)

Adhesion Force Imaging (AhFM)

Local Viscoelastisity Imaging (force modulation technique)

Spreading Resistance Imaging

AFM in liquids

#### ResonantMode

Special modulation technique for non-destructive imaging possible due to the elimination of lateral force influence.

Topography

Semicontact AFM

Noncontact AFM

Phase Imaging

Two-pass Techniques:

Magnetic Force Microscopy (MFM)

Electrostatic Force Microscopy (EFM)

Scanning Capacitance Microscopy (SCM)

Kelvin Probe Microscopy (SKM)

#### Lithography

Mechanical Influence

Scratching

Resonant Mode

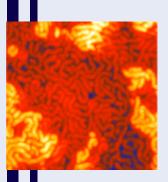
Electric Influence

#### SNOM

#### **Shear Force Mode - Topography Imaging**

Optical input/output

# **HIGHLIGHTS:**



Perpendicular wetting of float glass by the lamellae of a symmetric smectic liquid crystallineisotropic diblock film. Sample courtesy of Prof. Dr. Wim H. de Jeu, FOM Institute, Netherlands. Scan size: 879×911 nm.

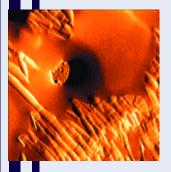
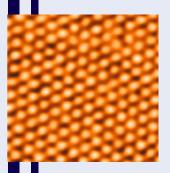


Image of Polydiethylsiloxane deposited on Si substrate by rubbing. Scan size:  $11x11 \mu m$ .



Lattice atomic resolution on Highly Oriented Pyrolytic Graphite obtained in STM mode in air. Scan size: 5x5 nm.

- Wide range of measuring techniques on air:
  contact AFM/ LFM/ ResonantMode (semicontact + noncontact
  AFM)/ Phase Imaging/ Force Modulation (viscoelastisity)/ MFM/
  EFM/ STM/ Adhesion Force Imaging/ Scanning Capacitance
  microscopy (SCM)/ Scanning Kelvin probe microscopy (SKM)/
  Spreading Resistance Imaging (SRI)/ STM, RM Lithography/
  AFM Lithography (Force+Voltage)/ STM Spectroscopy;
  in liquid: contact AFM/ LFM/ Adhesion Force Imaging/ Force
  Modulation (viscoelastisity)/ semicontact AFM (scanner-driven)/
  AFM lithography (Force).
- The measuring head allows switching between imaging techniques STM/ AFM/ LFM/ ResonantMode by a mouse click in the control program.
- The topography of the same area can be shown simultaneously with LFM, MFM/EFM or STM images for comparison purposes.
- NT-MDT guarantees an atomic resolution at the customer's location within usual laboratory environment, without special anti-vibration tables.
- Advanced electronics High-Q with 22-bit resolution in XY-plane allows to set the resonance frequency with an accuracy 0.01 Hz to use probes with highest Q-factor.
- Two 16-bit ADCs allow to measure up to four different signals during a single scanning procedure.
- Temperature control of the sample up to 150°C degrees with accuracy 0.1°C.
- Residual nonlinearity (in XY-plane) is less than 1%.
- The symmetric design of SPM scanning-measuring system provides a low thermal drift, allowing to start measurements immediately after switching on the system.
- The piezoceramic which is used in Solver line microscopes has much better aging characteristic in comparison with analogs, used in SPM.
- Low weight (30 kg) and compact design.
- Wide range of supply voltages (80-240 V, 50-60 Hz) can be used without additional voltage stabilization.
- Low power consumption − 100 W.
- NT-MDT can customize microscopes to fit your requirements. Any system configuration can be upgraded to the TOP featured system.
- NT-MDT SPM systems have the best price performance ratio.

To learn more about our products visit our web site http://www.ntmdt.com

